

501.43187X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Hiroyuki IKEDA, et al.
Serial No.: Not yet assigned
Filed: October 29, 2003
For: A METHOD OF MANUFACTURING A SEMICONDUCTOR
DEVICE AND A SEMICONDUCTOR DEVICE
Group: Not yet assigned
Examiner: Not yet assigned

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 29, 2003

Sir:

The following amendments and remarks are respectfully submitted in
connection with the above-identified application:

Amendments to the Claims